



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 13, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG788647943

Report verification at igi.org

PROPORTIONS

Slightly Thick

15%

49%

62%

68.3%

Long

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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LABORATORY GROWN DIAMOND REPORT

April 13, 2026

IGI Report No LG788647943

EMERALD CUT

9.76 X 6.25 X 4.27 MM

Carat Weight

Color Grade

Clarity Grade

Table

Grade

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

2.70 CARATS

E

VVS 1

68.3%

62%

Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

IGI LG788647943

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

IGI



IGI

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April 13, 2026

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